



MS AF  
REPLY UNDER  
37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2823

PATENT  
0941-0841P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Ming-Tsong WANG et al. Conf.: 5290  
Appl. No.: 10/660,573 Group: 2823  
Filed: September 12, 2003 Examiner: J.J. MALDONADO  
For: PROCESS FOR FORMING METAL DAMASCENE  
STRUCTURE TO PREVENT DIELECTRIC LAYER  
PEELING

AMENDMENT AFTER FINAL UNDER 37 C.F.R. § 1.116

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

December 9, 2004

Sir:

In reply to the Office Action dated October 5, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes: Amendments to the Claims and Remarks.